

# Surface Acoustic Wave Gas Sensor

A surface acoustic wave (SAW) is an acoustic wave propagating along the surface of a solid material. Its amplitude decays rapidly, often exponentially, with the depth of the material. SAWs are featured in many kinds of electronic components, including filters, oscillators, and sensors. SAW devices typically use electrodes on a piezoelectric material to convert an electric signal to a SAW, and back again.

In this model, you investigate the resonance frequencies of a SAW gas sensor. The sensor consists of an interdigitated transducer (IDT) etched onto a piezoelectric LiNbO<sub>3</sub> (lithium niobate) substrate and covered with a thin polyisobutylene (PIB) film. The mass of the PIB film increases as PIB selectively adsorbs CH<sub>2</sub>Cl<sub>2</sub> (dichloromethane, DCM) from air. This causes a shift in resonance which slightly lowers the resonance frequency for the same SAW mode.

# Model Definition

Figure 1 shows a conceptual view of the gas sensor in this model.

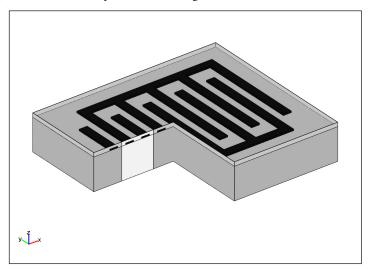


Figure 1: SAW gas sensor, showing the IDT electrodes (in black), the thin PIB film (light gray), and the LiNbO3 substrate (dark gray). For the sake of clarity, the dimensions are not to scale and the IDT has fewer electrodes than in common devices. A slice of the geometry is removed to reveal the modeled unit cell (in white).

IDTs used in SAW devices may have hundreds of identical electrodes, and each electrode can be about 100 times longer than it is wide. You can therefore neglect the edge effects and reduce the model geometry to the periodic unit cell shown in Figure 2. The height of this cell does not have to extend all the way to the bottom of the substrate but only a few wavelengths down, so that the SAW has almost died out at the lower boundary.

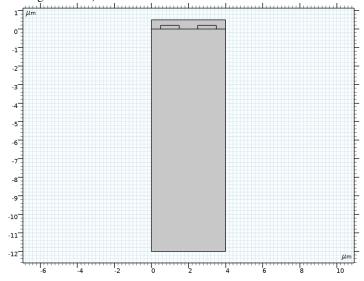


Figure 2: The geometry of the SAW unit cell used in this model. A 500 nm PIB film covers two  $1~\mu m$ -wide electrodes on top of the LiNbO $_3$  substrate. The substrate domain has a total height of 12 µm.

Set up the model using the predefined Piezoelectricity multiphysics interface. In 2D, a Plane Strain assumption is used for the Solid Mechanics interface. Hence the out-of-plane strain component is zero. This should be a valid assumption, considering that the SAW is generated in the plane of the model and hence any variation in the out-of-plane direction can be considered minimal.

#### **BOUNDARY CONDITIONS**

In order to define the model, you need to apply structural and electrical boundary conditions.

As one can assume that the surface wave dies off within two to three wavelengths from the surface, the lower boundary is fixed. This enforces a zero structural displacement but does not contribute to any significant reflection from the lower boundary back into the bulk of the substrate as long as we are observing surface waves and in particular Rayleigh waves.

The electrodes have a much higher electrical conductivity compared to PIB and LiNbO<sub>3</sub> Hence, one can expect each of the electrodes to be isopotential. This is why you do not need to model the domains that constitute the electrodes but can simply use appropriate boundary conditions on all the outer boundaries of each electrode to indicate what type of isopotential state it is in. The boundaries of the left terminal is set to electrical ground, and those of the right terminal are assigned to a Floating Potential with zero surface charge accumulation. This combination of electrical boundary conditions corresponds to an open circuit configuration, which is typically suitable for sensing applications.

Use periodic boundary conditions to dictate that the electric potential and displacements are the same along both vertical boundaries of the geometry. When using periodic boundary conditions, one needs to ensure that the mesh on the vertical boundaries on the left of the unit cell and the vertical boundaries on the right of the unit cell are identical. This is achieved by first creating the mesh on the vertical boundaries on the left and then using the Copy Edge feature to create the exact same mesh on the vertical boundaries on the right.

All other boundaries are left to the default boundary conditions which are Free for the Solid Mechanics interface and Zero Charge for the Electrostatics interface, respectively.

#### MATERIAL PROPERTIES

The substrate used in the simulation is YZ-cut LiNbO<sub>3</sub> with the following properties (cited in Ref. 2):

• Elasticity matrix:

• Coupling matrix:

$$\begin{bmatrix} 1.33 & 0.23 & 0.23 & 0 & 0 & 0 \\ 0 & 0 & 0 & -2.5 & 0 & 3.7 \\ 0 & -2.5 & 2.5 & 0 & 3.7 & 0 \end{bmatrix}$$

• Relative permittivity:

$$\begin{bmatrix} 28.7 & 0 & 0 \\ 85.2 & 0 \\ & 85.2 \end{bmatrix}$$

The density of the PIB film is from Ref. 1. The Poisson's ratio is considered to be 0.48, and the Young's modulus is set to 10 GPa

The adsorption of DCM gas is represented as a slight increase of the overall density of the PIB film as shown in the following expression.

$$\rho = \rho_{PIB} + \text{switch} \cdot \rho_{DCM,PIB}$$

In this model, you use a parameter, switch, whose value can be either 0 or 1. This allows to solve the model for two cases; once without the effect of adsorbed gas and once with the effect of the adsorbed DCM gas in PIB.

When the sensor is exposed to 100 ppm of DCM in air at atmospheric pressure and room temperature, the "partial density" of DCM in the PIB film can be calculated from

$$\rho_{\rm DCM,PIB} = KMc$$

where  $K = 10^{1.4821}$  (Ref. 1) is the air/PIB partition coefficient for DCM, M is its molar mass, and c

$$c = (c_0 p)/(RT)$$

is its concentration in air. The DCM concentration, c in moles/m<sup>3</sup> is computed using the Gas Law. Here  $c_0$  is the concentration in parts per million, p is the pressure, T is the temperature, and R is the gas constant. Any effects of the DCM adsorption on the material properties other than the density are neglected.

Most of the material properties and factors affecting them have been parameterized as shown in Table 1. This easily allows the model to be adapted for other materials and operating conditions.

TABLE I: LIST OF PARAMETERS.

NAME	EXPRESSION	DESCRIPTION
P	I [atm]	Air pressure
Т	25[degC]	Air temperature
c0	100	DCM concentration in ppm
c_DCM_air	10-6*c0*p/(R_const*T)	DCM concentration in air
M_DCM	84.93[g/mol]	Molar mass of DCM
K	10^1.4821	PIB/air partition constant for DCM
rho_DCM_PIB	K*M_DCM*c_DCM_air	Mass concentration of DCM in PIB
rho_PIB	0.918[g/cm^3]	Density of PIB
E_PIB	I0[GPa]	Young's modulus of PIB
nu_PIB	0.48	Poisson's ratio of PIB
eps_PIB	2.2	Relative permittivity of PIB
switch	0	Switch for adding DCM density
vR	3488[m/s]	Rayleigh wave velocity
width	4[um]	Width of unit cell
f0	vR/width	Estimated SAW frequency
t_PIB	0.5[um]	PIB thickness

#### ESTIMATING THE SAW FREQUENCY

The use of periodic boundary condition implies that the frequencies of interest correspond to wavelengths that are integer fractions of the width of the geometry. The lowest SAW eigenmode has its wavelength equal to the width of the geometry, that is, 4 µm. Using this along with the Rayleigh wave velocity for the given piezoelectric substrate material, one can find an estimate of the resonance frequency of interest. The information can be used in the eigenfrequency solver, which helps it to find out the resonance frequencies close to this estimated number. In this model, you use a YZ-cut LiNbO3 whose Rayleigh wave velocity (vR) is around 3488 m/s. This gives an estimate of the lowest SAW frequency (f0) to be 872 MHz.

# Results and Discussion

The antiresonance and resonance frequencies evaluate to approximately 850 MHz and 855 MHz, respectively. Figure 3 and Figure 4 show the corresponding SAW modes. Figure 5 and Figure 6 show the electric potential distribution characteristics for these solutions.

Exposing the sensor to a 100 ppm concentration of DCM in air leads to a resonance frequency shift of approximately 200 Hz downward. This shift is computed by evaluating the resonance frequency before and after adding the density of adsorbed DCM to that of the PIB domain.

Note that the computational mesh is identical in both these solutions. This implies that the relative error of the frequency shift is similar to that of the resonance frequency itself. Thus, the shift is accurately evaluated despite being a few magnitudes smaller than the absolute error of the resonance frequency.

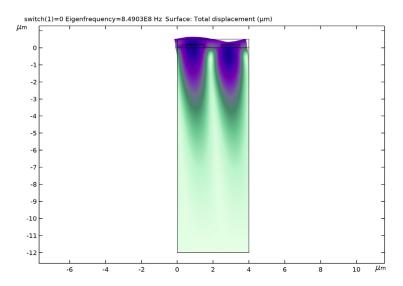


Figure 3: Deformed shape plot of the antiresonance SAW mode.

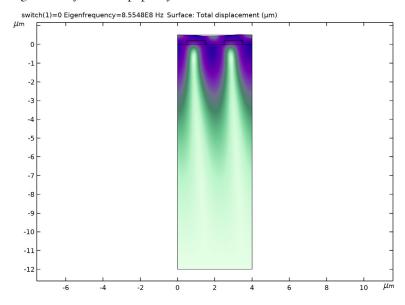


Figure 4: Deformed shape plot of the resonance SAW mode.

switch(1)=0 Eigenfrequency=8.4903E8 Hz Surface: Electric potential (V)

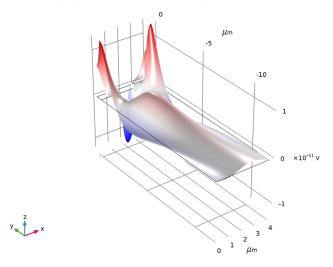


Figure 5: Electric potential distribution and deformations at antiresonance, antisymmetric with respect to the center of each electrode.

switch(1)=0 Eigenfrequency=8.5548E8 Hz Surface: Electric potential (V)

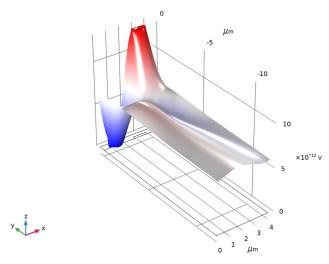


Figure 6: Electric potential distribution at resonance, symmetric with respect to the center of each electrode.

- 1. K. Ho, E. R. Lindgren, K. S. Rawlinson, L. K. McGrath, and J. L. Wright, "Development of a Surface Acoustic Wave Sensor for In-Situ Monitoring of Volatile Organic Compounds," Sensors vol. 3, pp. 236-247, 2003.
- 2. S. Ahmadi, F. Hassani, C. Korman, M. Rahaman, and M. Zaghloul, "Characterization of Multi- and Single-layer Structure SAW Sensor," Sensors 2004, Proceedings of IEEE, vol. 3, pp. 1129-1132, 2004.

Application Library path: Acoustics Module/Ultrasound/saw gas sensor

# Modeling Instructions

From the File menu, choose New.

#### NEW

In the New window, click Model Wizard.

#### MODEL WIZARD

- I In the Model Wizard window, click 2D.
- 2 In the Select Physics tree, select Structural Mechanics>Piezoelectricity.
- 3 Click Add.
- 4 Click Study.
- 5 In the Select Study tree, select Preset Studies for Selected Multiphysics>Eigenfrequency.
- 6 Click Done.

## **GEOMETRY I**

For quicker modeling, load the parameters from a file.

# **GLOBAL DEFINITIONS**

## Parameters 1

- I In the Model Builder window, under Global Definitions click Parameters I.
- 2 In the Settings window for Parameters, locate the Parameters section.
- 3 Click Load from File.

4 Browse to the model's Application Libraries folder and double-click the file saw gas sensor parameters.txt.

#### **GEOMETRY I**

- I In the Model Builder window, under Component I (compl) click Geometry I.
- 2 In the Settings window for Geometry, locate the Units section.
- 3 From the Length unit list, choose  $\mu m$ .

#### Rectangle I (rI)

- I In the Geometry toolbar, click Rectangle.
- 2 In the Settings window for Rectangle, locate the Size and Shape section.
- 3 In the Width text field, type width.
- 4 In the Height text field, type 3\*width+t PIB.
- 5 Locate the **Position** section. In the y text field, type -3\*width.
- **6** Click to expand the **Layers** section. In the table, enter the following settings:

Layer name	Thickness (µm)
Layer 1	t_PIB

- 7 Select the Layers on top check box.
- **8** Clear the **Layers on bottom** check box.
- 9 Click Build Selected.

# Rectangle 2 (r2)

- I In the Geometry toolbar, click Rectangle.
- 2 In the Settings window for Rectangle, locate the Size and Shape section.
- 3 In the Width text field, type width/4.
- 4 In the Height text field, type 0.4\*t PIB.
- 5 Locate the **Position** section. In the **x** text field, type width/8.
- 6 Click Build Selected

# Copy I (copy I)

- I In the Geometry toolbar, click Transforms and choose Copy.
- **2** Select the object **r2** only.
- 3 In the Settings window for Copy, locate the Displacement section.
- 4 In the x text field, type width/2.

# 5 Click Build All Objects.

Before creating materials, define the domains where each physics apply.

## SOLID MECHANICS (SOLID)

Piezoelectric Material I

- I In the Model Builder window, under Component I (compl)>Solid Mechanics (solid) click Piezoelectric Material I.
- 2 In the Settings window for Piezoelectric Material, locate the Domain Selection section.
- 3 Click Clear Selection.
- **4** Select Domain 1 only.

# **ELECTROSTATICS (ES)**

The electrical equations are not solved in the aluminum electrodes because they are assumed to be perfect conductors compared to LiNbO3 and PIB, and hence we consider them to be equipotential regions.

- I In the Model Builder window, under Component I (compl) click Electrostatics (es).
- 2 Select Domains 1 and 2 only.

Charge Conservation, Piezoelectric I

- I In the Model Builder window, under Component I (compl)>Electrostatics (es) click Charge Conservation, Piezoelectric I.
- 2 Select Domain 1 only.

#### MATERIALS

Material I (mat I)

- I In the Model Builder window, under Component I (compl) right-click Materials and choose Blank Material.
- 2 In the Settings window for Material, type LiNb03 in the Label text field.
- 3 Locate the Geometric Entity Selection section. Click Clear Selection.
- **4** Select Domain 1 only.

**5** Locate the **Material Contents** section. In the table, enter the following settings:

Property	Variable	Value	Unit	Property group
Elasticity matrix, Voigt notation	{cE11, cE12, cE22, cE13, cE23, cE33, cE14, cE24, cE34, cE44, cE15, cE25, cE35, cE45, cE55, cE16, cE26, cE36, cE46, cE56, cE66}; cEij = cEji	{242.4[GPa], 75.2[GPa],203[GPa], 75.2[GPa],57.3[GPa], 203[GPa],0,0,0, 75.2[GPa],0,8.5[GPa], -8.5[GPa],0, 59.5[GPa],0,0,0, 8.5[GPa],0,59.5[GPa]}	Pa	Stress-charge form
Coupling matrix, Voigt notation	{eES11, eES21, eES31, eES12, eES22, eES32, eES13, eES23, eES33, eES14, eES24, eES34, eES15, eES25, eES35, eES16, eES26, eES36}	{1.33,0,0,0.23,0,- 2.5,0.23,0,2.5,0,- 2.5,0,0,0,3.7,0,3.7, 0}	C/m²	Stress-charge form
Relative permittivity	{epsilonrS11, epsilonrS22, epsilonrS33}; epsilonrSij = 0	{28.7,85.2,85.2}	I	Stress-charge form
Density	rho	4647	kg/m³	Basic

Alternately, you can click the **Edit** button below the **Output properties** table and use the matrix inputs to enter cE, e, and epsilonrS according to the material data shown under the Model Definition section.

# Material 2 (mat2)

- I Right-click Materials and choose Blank Material.
- 2 In the Settings window for Material, type PIB in the Label text field.
- 3 Select Domain 2 only.

**4** Locate the **Material Contents** section. In the table, enter the following settings:

Property	Variable	Value	Unit	Property group
Young's modulus	E	E_PIB	Pa	Basic
Poisson's ratio	nu	nu_PIB	1	Basic
Density	rho	rho_PIB+switch* rho_DCM_PIB	kg/m³	Basic
Relative permittivity	epsilonr_iso; epsilonrii = epsilonr_iso, epsilonrij = 0	eps_PIB	I	Basic

#### ADD MATERIAL

- I In the Home toolbar, click Add Material to open the Add Material window.
- 2 Go to the Add Material window.
- 3 In the tree, select Built-in>Aluminum.
- 4 Click Add to Component in the window toolbar.
- 5 In the Home toolbar, click Add Material to close the Add Material window.

#### MATERIALS

Aluminum (mat3)

Select Domains 3 and 4 only.

# SOLID MECHANICS (SOLID)

Fixed Constraint I

- I In the Model Builder window, under Component I (compl) right-click Solid Mechanics (solid) and choose Fixed Constraint.
- 2 Select Boundary 2 only.

Periodic Condition I

- I In the Physics toolbar, click Boundaries and choose Periodic Condition.
- 2 Select Boundaries 1, 3, 16, and 17 only.

This defines periodic condition for the **Solid Mechanics** physics. By default, the periodicity type is set to **Continuity** for all dependent variables.

# **ELECTROSTATICS (ES)**

Ground the left electrode by applying boundary condition on its edges.

#### Ground 1

- I In the Model Builder window, under Component I (compl) right-click Electrostatics (es) and choose Ground.
- 2 Select Boundaries 6–9 only.

Apply a **Floating Potential** on the edges of the right electrode.

# Floating Potential I

- I In the Physics toolbar, click Boundaries and choose Floating Potential.
- **2** Select Boundaries 11–14 only.

Define periodic boundary condition for the **Electrostatics** physics.

#### Periodic Condition I

- I In the Physics toolbar, click Boundaries and choose Periodic Condition.
- 2 Select Boundaries 1, 3, 16, and 17 only.

#### MESH I

# Edge 1

- I In the Model Builder window, under Component I (compl) right-click Mesh I and choose More Operations>Edge.
- 2 Select Boundaries 1 and 3 only.

## Distribution I

- I Right-click **Edge I** and choose **Distribution**.
- 2 Select Boundary 3 only.
- 3 In the Settings window for Distribution, locate the Distribution section.
- 4 In the Number of elements text field, type 4.

## Edge 1

Define an increasing mesh size along the thickness of the piezoelectric substrate.

#### Distribution 2

- I In the Model Builder window, right-click Edge I and choose Distribution.
- 2 Select Boundary 1 only.
- 3 In the Settings window for Distribution, locate the Distribution section.
- 4 From the Distribution type list, choose Predefined.

- 5 In the Number of elements text field, type 25.
- 6 In the Element ratio text field, type 25.
- 7 Select the Reverse direction check box.
- 8 Click Build Selected.

# Copy Edge I

- I In the Model Builder window, right-click Mesh I and choose More Operations>Copy Edge.
- **2** Select Boundaries 1 and 3 only.
- 3 In the Settings window for Copy Edge, locate the Destination Boundaries section.
- 4 Select the Activate selection toggle button.
- **5** Select Boundaries 16 and 17 only.

## Free Quad I

- I Right-click Mesh I and choose Free Quad.
- 2 In the Settings window for Free Quad, locate the Domain Selection section.
- 3 From the Geometric entity level list, choose Domain.
- 4 Select Domains 2–4 only.

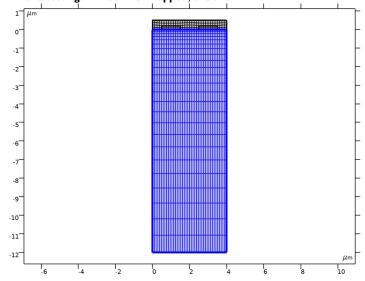
#### Size 1

- I Right-click Free Quad I and choose Size.
- 2 In the Settings window for Size, locate the Element Size section.
- **3** Click the **Custom** button.
- 4 Locate the Element Size Parameters section. Select the Maximum element size check box.
- 5 In the associated text field, type t PIB/4.

#### Mapped I

I In the Model Builder window, right-click Mesh I and choose Mapped.

2 In the Settings window for Mapped, click Build All.



# STUDY I

Set up a Parametric Sweep to solve the model with and without the adsorbed species on the sensor. The parameter switch is used to solve the model once without adding the density of DCM and once with the added density of adsorbed DCM in PIB.

# Parametric Sweep

- I In the Study toolbar, click Parametric Sweep.
- 2 In the Settings window for Parametric Sweep, locate the Study Settings section.
- 3 Click Add.
- **4** In the table, enter the following settings:

Parameter name	Parameter value list	Parameter unit
switch (Switch for adding DCM density)	0 1	

Search for eigenfrequencies near the estimated resonance frequency.

# Step 1: Eigenfrequency

- I In the Model Builder window, click Step I: Eigenfrequency.
- 2 In the Settings window for Eigenfrequency, locate the Study Settings section.
- 3 Select the Search for eigenfrequencies around check box.

- **4** In the associated text field, type f0.
- 5 In the Study toolbar, click Compute.

#### RESULTS

Mode Shape (solid)

The default plot shows the anti-resonance SAW mode near 850 MHz. Adjust the deformed shape plot to see the effect of the wave localization near the surface.

- I In the Settings window for 2D Plot Group, locate the Data section.
- 2 From the Parameter value (switch) list, choose 0.
- 3 In the Model Builder window, expand the Mode Shape (solid) node.

## Deformation

- I In the Model Builder window, expand the Results>Mode Shape (solid)>Surface I node, then click **Deformation**.
- 2 In the Settings window for Deformation, locate the Scale section.
- 3 Select the Scale factor check box.
- 4 In the associated text field, type 5e13.
- 5 In the Mode Shape (solid) toolbar, click Plot.
- **6** Click the **Zoom Extents** button in the **Graphics** toolbar.

Compare the resulting plot to that in Figure 3.

Plot the second mode shape near 855 MHz, which is the resonance SAW mode.

7 Click Plot.

# Mode Shape (solid)

- I In the Model Builder window, click Mode Shape (solid).
- 2 In the Settings window for 2D Plot Group, locate the Data section.
- 3 From the Eigenfrequency (Hz) list, choose 8.5548E8.
- 4 In the Mode Shape (solid) toolbar, click Plot.
- 5 Click the **Zoom Extents** button in the **Graphics** toolbar.

Compare the resulting plot to that in Figure 4.

# Electric Potential (es)

To visualize the electric potential distribution for the eigenmodes, follow these steps.

## Surface I

- I In the Model Builder window, expand the Results>Electric Potential (es) node, then click Surface 1.
- 2 In the Settings window for Surface, locate the Coloring and Style section.
- 3 From the Color table list, choose WaveLight.

# Height Expression I

Right-click Surface I and choose Height Expression.

## Electric Potential (es)

- I In the Settings window for 2D Plot Group, locate the Color Legend section.
- **2** Clear the **Show legends** check box.
- 3 Locate the Data section. From the Parameter value (switch) list, choose 0.
- 4 In the Electric Potential (es) toolbar, click Plot.
- 5 Click the **Zoom Extents** button in the **Graphics** toolbar.
- 6 From the Eigenfrequency (Hz) list, choose 8.5548E8.
- 7 In the Electric Potential (es) toolbar, click Plot.
- 8 Click the **Zoom Extents** button in the **Graphics** toolbar.

#### Derived Values

To see all computed eigenfrequencies as a table, follow these steps.

#### Global Evaluation 1

- I In the Results toolbar, click Global Evaluation.
- 2 In the Settings window for Global Evaluation, locate the Data section.
- 3 From the Dataset list, choose Study I/Parametric Solutions I (sol2).
- 4 From the Table columns list, choose Outer solutions.
- 5 Click Replace Expression in the upper-right corner of the Expressions section. From the menu, choose Solver>freq - Frequency - Hz.
- 6 Click New Table.

#### TABLE

- I Go to the **Table** window.
- 2 Click Full Precision in the window toolbar.

The first 6 digits of the eigenfrequency are the same. Subtracting the new value from the previous value shows that the eigenfrequency with gas exposure is lower by 200 Hz.